

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Satya et al

Attorney Docket No.: KLA1P016F

Application No.: 09/648,095

Examiner: Not assigned

Filed: August 25, 2000

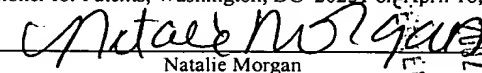
Group: 2858

Title: CHEMICAL MECHANICAL POLISHING
TEST STRUCTURES AND METHODS FOR
INSPECTING THE SAME

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the
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INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§1.56 AND 1.97(c)

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. KLA1P016F).

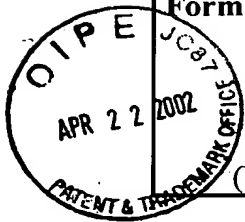
Respectfully submitted,

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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. KLA1P016F Applicant: Satya, et al Filing Date August 25, 2000	Application No.: 09/648,095 Group 2858
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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A1	6,091,249	7/18/2000	Talbot, et al.	324	751	1/23/98
	A2	6,061,814	5/9/2000	Sugasawara	714	724	4/21/98
	A3	5,804,459	9/8/1998	Bolam, et al.	453	12	11/15/96
	A4	6,292,582B1	9/18/2001	Lin, et al.	382	149	5/30/97
	A5	6,265,232B1	7/24/2001	Simmons	434	14	8/21/98
	A6	5,578,821	11/26/96	Meisberger, et al.	250	310	1/11/95
	A7	4,902,967	2/20/1990	Flesner	324	158	5/18/89
	A8	6,252,412B1	6/26/2001	Talbot, et al.	324	750	1/8/99
	A9	6,344,750B1	2/5/2002	Lo, et al.	324	751	1/8/99
	A10	6,324,298B1	11/27/2001	O'Dell, et al.	382	149	7/13/99
	A11	5,489,852	2/6/96	Gomez	324	754	11/6/92

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	B1							
	B2							
	B3							
	B4							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
	C2	
	C3	
Examiner		Date Considered

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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.